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PATENT & TRADEMARK OFFICE

Docket No. 42598-2300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Patent Examiner:
Hideya Kobayashi	Group Art Unit: 1744
Serial No.: 10/684,597	March 3, 2004
Filed: October 14, 2003	
For: LENS CLEANER AND LENS CLEANING METHOD FOR OPTICAL DISC DEVICES	Irvine, California 92614

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In an attempt to fully comply with the duty of disclosure set forth in 37 C.F.R. § 1.56 and in conformance with 37 C.F.R. §§ 1.97 and 1.98, applicant wishes to bring to the attention of the U.S. Patent Office the following references:

Patent Abstracts of Japan Publication No. 64-043386
Patent Abstracts of Japan Publication No. 01-140482
Patent Abstracts of Japan Publication No. 63-313378

Copies of these references and a form PTO-A820 are attached.

If the Examiner believes that a telephone conference would help further the prosecution of this case, he is respectfully requested to contact the undersigned attorney at the listed telephone number.

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Commissioner for Patent, PO Box 1450, Alexandria, VA 22313-1450 on March 3, 2004

by: James Lee

Signature

Date of Signature: March 3, 2004

Very truly yours,

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INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)

Docket Number (Optional)	Application Number
42598-2300	10/684,597
Applicant(s)	
Hideya Kobayashi	
Filing Date	**Group Art Unit**
10/14/2003	1744

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	Translation NO
		64-043386	15/02/1989	Patent Abstracts of Japan			✓	
		01-140482	01/06/1989	Patent Abstracts of Japan			✓	
		63-313378	21/12/1988	Patent Abstracts of Japan			✓	

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

EXAMINER	DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.